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DT12 PCT/PTO 13 DEC 2004

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masakazu SATO et al.

Application No.: New U.S. National Stage of
PCT/JP03/07320

Filed: December 13, 2004

Docket No.: 122035

For: METHOD OF EVALUATING SHAPE OF SEMICONDUCTOR WAFER AND
APPARATUS FOR EVALUATING SHAPE OF SEMICONDUCTOR WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

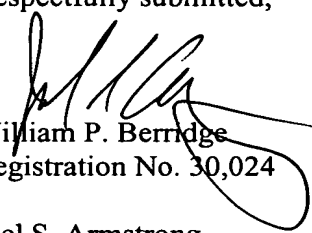
- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references 1-5 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 3. English language Abstracts of the non-English language references 1-5 are attached hereto.

JT12 Rec'd PCT/PTO 13 DEC 2004



4. A computer-generated English language translation of the following Japanese references has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1-4.

Respectfully submitted,



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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 122035		APPLICATION NO. New U.S. National Stage of PCT/JP03/07320	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Masakazu SATO et al.			
				FILING DATE December 13, 2004			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1	JP A 11-287630 w/abstr. + trans.	10/19/1999	Japan			
	2	JP A 9-148413 w/abstr. + trans.	06/06/1997	Japan			
	3	JP A 2001-41736 w/abstr. + trans.	02/16/2001	Japan			
	4	JP A 2000-292152 w/abstr. + trans.	10/20/2000	Japan			
	5	JP A 2-083404 w/abstract	03/23/1990	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: December 13, 2004